





Design and Analysis of Three DOF Piezoelectric Vibration Energy Harvester

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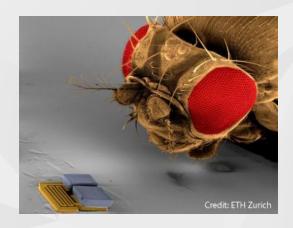
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Outline

- Introduction to MEMS
- Vibration Energy Harvester
- Design Structure
- Working Principle and Theoretical Analysis
- COMSOL Simulation
- Conclusion and Future Work

What is MEMS?

- MEMS: Micro-Electro-Mechanical Systems
- Definition: Devices and Systems integrated electrical and mechanical components with micron scale.
- Typical MEMS Devices:
 MEMS Pressure Sensor, Accelerometer,
 Gyroscope, Micro-motor, resonator, Oscillators,
 Micro-mirror, Optical switch, RF capacitor etc.



MEMS-and-Bug ETH Zurich

What are Vibration Energy Harvesters

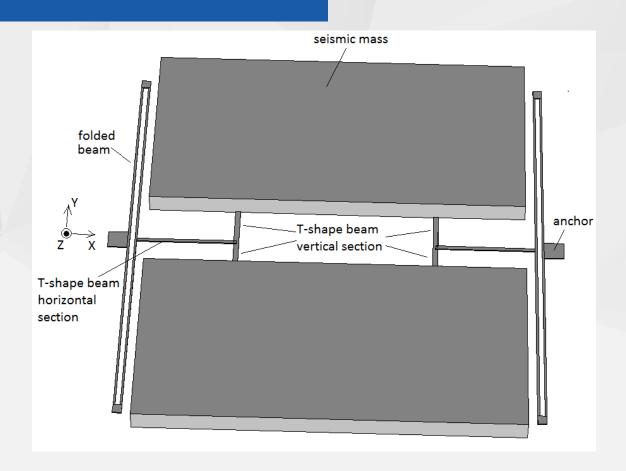
Vibration Energy Harvester device harvests wasted energy from mechanical vibrations.

- Piezoelectric materials help energy harvesters to convert mechanical energy into alternating electrical energy (AC).
- AC then electronically converted to DC, which can be used to drive a multitude of wireless applications or to recharge a battery.



A Simple Cantilever Piezoelectric Energy Harvester

Device Structure Design



Working Principle

- The device consists of two mass blocks suspended by four sets of folded beams and two sets of T-shape beams. The folded beams are fixed by two anchors.
- Piezoelectric thin films with top/bottom metal electrodes are pre-deposited on the bottom surface of the T-shape beams. The seismic masses are much thicker than the beams, thus its mass center is above the plane of the beams. This imbalance is intentionally designed to induce out-of-plane movement of both Tshape beams when in-plane vibration is sensed..
- The resulted stress along the beams causes the piezoelectric films to generate electrical voltage output which is passed through a rectifying circuit to charge a battery.

Theoretical Analysis

• The width, length and thickness of each folded beam section are W_{fb} , L_{fb} , t_b respectively. The width, length and thickness of the horizontal section of the T-shape beam are W_{tb1} , L_{tb1} , t_b respectively. The width, length and thickness of each vertical section of the T-shape beam are W_{tb2} , L_{tb2} , t_b respectively. The width, length and thickness of one seismic mass are W_m , L_m and t_m respectively. Density of silicon is ρ , and Young's modulus of silicon is E.

Theoretical Analysis: Resonant Frequency along X direction

☐ The total spring constant of the device along X direction is

$$K_{X_tot} = \frac{K_{fb_xtot} \cdot K_{tb2_xtot}}{K_{fb_xtot} + K_{tb2_xtot}}$$

The total mass of two seismic masses is

$$M = 2\rho W_m L_m t_m$$

Ignoring the mass of piezoelectric films and its top/bottom electrodes, and treating the energy harvester as simplified springmass system, the resonant frequency of the energy harvester along X direction is $f_x = \frac{1}{2\pi} \sqrt{\frac{K_{X_tot}}{M}}$

Theoretical Analysis: Resonant Frequency along Y direction

☐ The total spring constant of the device along Y direction is

$$K_{Y_{_tot}} = 2EW_{tb1}^3 \cdot t_b / L_{tb1}^3$$

The resonant frequency of the energy harvester along Y direction is

$$f_{y} = \frac{1}{2\pi} \sqrt{\frac{K_{Y_tot}}{M}}$$

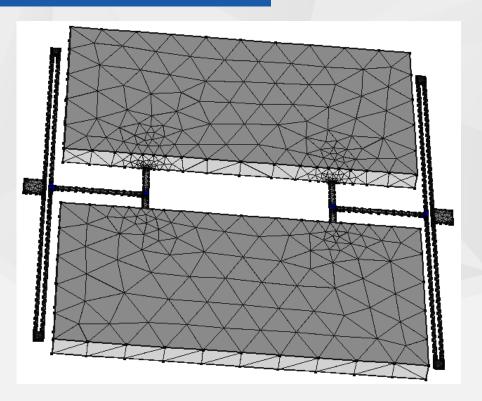
Theoretical Analysis: Resonant Frequency along Z direction

☐ The total spring constant of the device along Z direction is

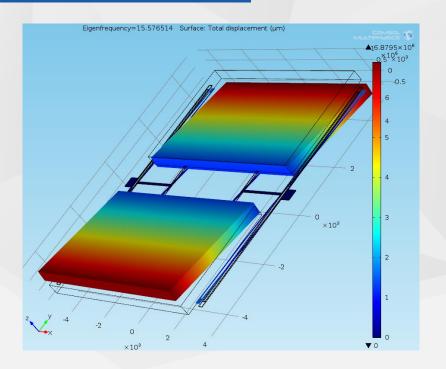
$$K_{Z_{-tot}} = \frac{1}{(1/K_{fb_{-}ztot} + 1/K_{tb1_{-}ztot} + 1/K_{tb2_{-}ztot})}$$

The resonant frequency of the energy harvester along Z direction is

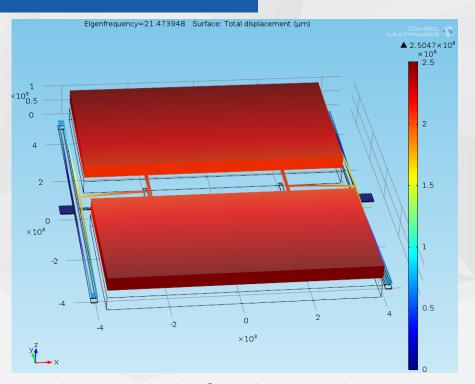
$$f_z = \frac{1}{2\pi} \sqrt{\frac{K_{Z_{-tot}}}{M}}$$



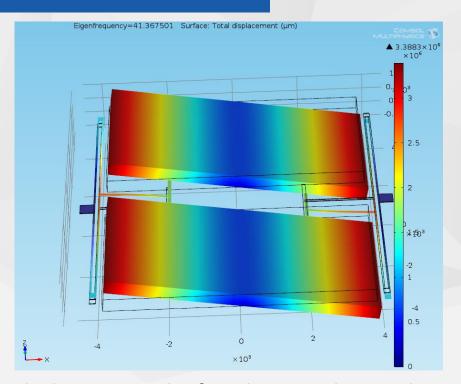
COMSOL meshed model of energy harvester



First vibration mode: for vibration along Y-direction (resonant frequency $f_y = 15.57514Hz$)



Second vibration mode: for vibration along Z-direction (resonant frequency $f_z = 21.473948Hz$)



Third vibration mode: for vibration along X-direction (resonant frequency $f_x = 41.367501Hz$)

Device Application



Shoe with vibration energy harvester inserted in its sole

Conclusion

- A Novel MEMS piezoelectric Vibration Energy Harvester with Three-DOF Responses is proposed.
- The device has different thickness for its beams and the seismic masses. Due to this imbalance, the inertial force resulted from input vibration leads to a net torque and converts in-plane vibration into out-of-plane movement of the Tshape beams.
- COMSOL simulation is used to simulate its vibrational modes and the corresponding resonant frequencies were derived.
- From the COMSOL simulation results, the working vibration modes in X and Y and Z directions have resonant frequencies of f_x =41.367501Hz, f_y =15.57514Hz and f_z = 21.473948Hz respectively.
- The energy harvester converts the mechanical energy into electrical energy and then stores the energy harvested in the capacitors

Future Scope

- In the future, we will perform stress simulation to find out the maximum stress induced inside the T-shape beams due to input vibrations along X, Y and Z directions.
- We will also perform piezoelectric simulation to find out the actual voltage output due to input vibrations.

Thank you!



Questions?